

Notice of References Cited	Application/Control No. 09/891,192	Applicant(s)/Patent Under Reexamination IRIE, SHIGEO	
	Examiner Saleha R. Mohamedulla	Art Unit 1756	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	C	US-6,245,491	06-2001	Shi	430/322
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	K	US-			
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	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	www.lamrc.com, TCP® 9400DFM-Silicon Etch, 7/24/03, Lam RESEARCH®, 3 pgs.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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